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<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(use as many sheets as necessary)</p>				<p>Complete if Known</p> <table border="1"> <tr> <td>Application Number</td> <td>10/519,953</td> </tr> <tr> <td>Filing Date</td> <td>September 14, 2005</td> </tr> <tr> <td>First Named Inventor</td> <td>Hiroshi ICHIGAYA</td> </tr> <tr> <td>Art Unit</td> <td>3744</td> </tr> <tr> <td>Examiner Name</td> <td>Melvin Jones</td> </tr> </table>		Application Number	10/519,953	Filing Date	September 14, 2005	First Named Inventor	Hiroshi ICHIGAYA	Art Unit	3744	Examiner Name	Melvin Jones
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Art Unit	3744														
Examiner Name	Melvin Jones														
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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PCT/ISA/210 from PCT/JP02/07021

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Sheet 1 of 1
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FORM PTO-1449 U.S. Department of Commerce Patent & Trademark Office		Attorney Docket No. 101539.55743US	Serial No. To Be Assigned
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant: Hiroshi ICHIGAYA	
		Filing Date Concurrently Herewith	Group To Be Assigned

U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
	AA						
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FOREIGN PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	TRANSLATION	
							Yes	No
MS	AK	WO 00/06006 A	2/10/2000	Seft Development Laboratory Co., Ltd.				
MS	AL	JP 4-209809 A	7/31/1992	Daikin Industries, Ltd.				
MS	AM	JP 2001-40512 A	2/13/2001	Seft Development Laboratory Co., Ltd.				
	AN							
	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
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